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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **KANO, Takashi et al.**

Group Art Unit: 2812

Serial No.: 09/941,982

Examiner: **MULPURI, Savitri**

Filed: **August 30, 2001**

P.T.O. Confirmation No.: 7536

For. **METHOD OF FORMING NITRIDE-BASED SEMICONDUCTOR LAYER, AND  
METHOD OF MANUFACTURING NITRIDE-BASED SEMICONDUCTOR  
DEVICE**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 8, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated January 8, 2003 for three months from April 8, 2003 to July 8, 2003.

Attached please find a check in the amount of \$840.00 to cover the cost of the extension for a large entity (2 months \$410.0 already paid on June 9, 2003). In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

  
Stephen G. Adrian

Attorney for Applicants

Reg. No. 32,878

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Atty. Docket No. 011083

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